Electronic Patent Application Fee Transmittal							
Application Number:	10565107						
Filing Date:	05-Mar-2007						
Title of Invention:	Plasma Surface Processing System and Supply Device for Plasma Processing Solution Therefor						
First Named Inventor/Applicant Name:	Young-Man Jeong						
Filer:	Esther Hyeri Chong/Ruth Calendine						
Attorney Docket Number:	0630-2627PUS1						
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Filing	Fee	s					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							
Extension - 1 month with \$0 paid		1251	1	130	130		

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$)			130